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- (71) Applicants
 Sierra Instruments, Inc.,
 P.O. Box 909, Carmel
 Valley, California 93924,
 United States of America
- (72) Inventors

 John G. Olin,

 Norman C. Ahlquist
- (74) Agents Mewburn Ellis & Co.

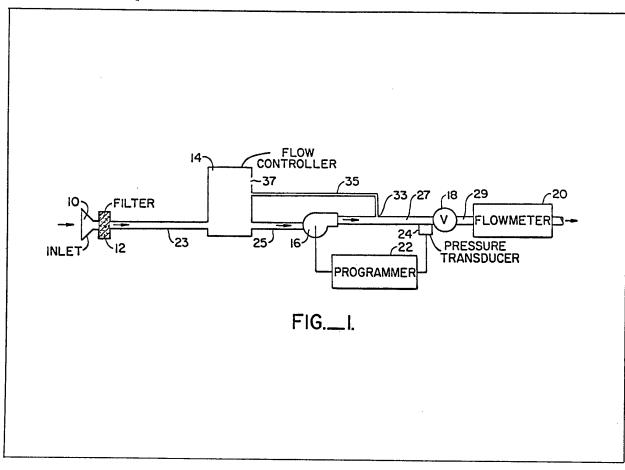
(54) Method and apparatus for sampling of a particle-bearing gas

(57) In a method and apparatus for sampling a particle-bearing gas a pump (16) applies reduced pressure to the gas to generate a stream of gas and particles are collected from the stream. A constant flow controller (14) responsive to the static pressure of the gas in the stream downstream of the pump (16) communicated to it via duct (35) provides a flow restriction upstream of the pump (16) which gradually decreases to

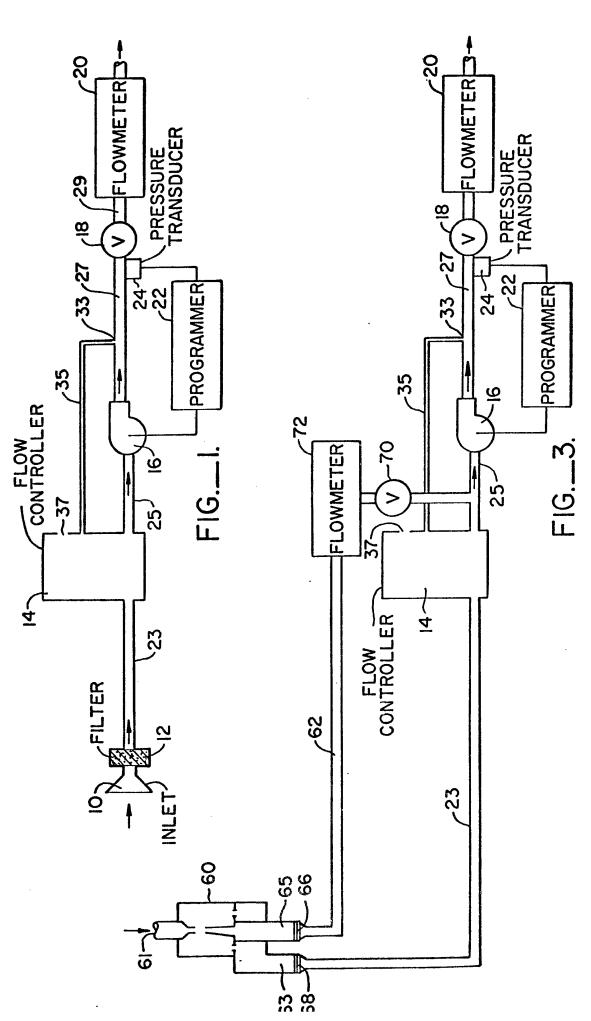
compensate for particles collecting on an initially particle-free collection filter (12) located in the stream. The flow rate may be set by a valve (18) and timed by a programmer (22) which may also cut off the pump if unduly low flow rates are detected.

The arrangement allows the pump (16) to work at a substantially constant rate and so facilitates the calculation of the total volume of gas which has passed through the filter.

The apparatus may include a dichotomous particle trapping device such as a virtual impactor.



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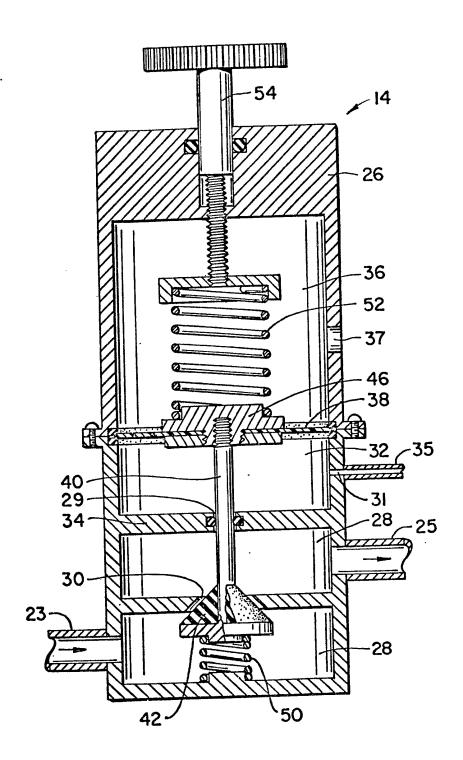


FIG._2.

SPECIFICATION

Method and apparatus for sampling of a particle-bearing gas

This invention relates to a method and apparatus for the determination of particle concentration in a particle-bearing sample gas. More specifically, this invention relates to maintaining the rate of flow of the gas relatively constant during sampling so that the volume of gas sampled and therewith the concentration of particles in the gas can be more readily and accurately determined.

In conventional gas sampling devices, such as those used to determine the concentration of solid 15 particulate matter suspended in air, a vacuum is applied to the sample gas so as to generate a flowing stream of gas. A filter of a specific pore size for filtering particles greater than a predetermined size collects particles from the 20 flowing stream of gas. The filter is weighed before and after the sampling period so as to determine the total weight of particles greater than a predetermined size collected during the sampling period. Over a period of time, for example, a 24 25 hour sampling period, the flow rate past the filter decreases as particles collect on the filter. This flow rate reduction can be quite significant, for example up to 50% over a 24 hour period, when the particles being collected from the gas are 30 substances, such as soot, which tend to clog the collection filter.

In order to determine the average number of particles per unit volume in the sample gas it is necessary to determine the total volume of gas which has passed through the collection filter.

Because of the reduction in flow rate caused by the collection of particles on the filter, the conventional practice has been to compute the average flow rate of the gas from measured initial and final flow rates. Obviously such a computation is accurate only if the decrease in flow rate is linear with time.

A recent development in the area of particle-bearing gas sampling devices is the virtual
impactor, a dichotomous gas sampler which divides the gas into two flow paths. The gas in the two paths flows at substantially different flow rates and bears particles of different sizes. With this recent development in which a single vacuum source applies a vacuum to the sample gas and the flow of the gas is divided into two paths, each path having its own filter for the collection of particles of a predetermined size, the accuracy of the conventional computational method to arrive at the total volume of gas sampled and thus the particle concentration of the different sized particles, becomes even more suspect.

It is apparent that the computation of particle concentration in a sample gas can be more readily and accurately determined if the flow rate of the stream of gas generated by the vacuum source can be maintained constant throughout the sampling period. One method of maintaining the flow rate of the stream of sample gas constant

65 involves varying the speed of the vacuum source, i.e., the vacuum pump, in response to the mass flow rate sensed proximate the collection filter by a flow rate transducer. As particles collect on the filter and the flow rate decreases, the pump speed
70 must increase to increase the flow rate. Such a method is complex and has proven to have a high failure rate, with a resultant increase in manpower and servicing costs.

In an alternative method, generally used in only high volume gas samplers, a flow regulator sensitive to the dynamic pressure of the relatively high velocity gas, maintains the flow rate constant. The flow regulator comprises a movable circular disk located in the stream between the filter and the pump and having its working surface oriented normal to the direction of the flowing

oriented normal to the direction of the flowing gas. The disk is restrained by a spring which is compressed by the dynamic pressure of the flowing gas acting on the working surface of the disk. The disk is thus movable longitudinally within the conduit confining the stream. The portion of the conduit surrounding the disk has a generally

conical shape which converges in a downstream direction so that the area of the annular opening defined by the outer periphery of the disk and the inner wall of the conical portion of the conduit varies with the longitudinal position of the disk in the conduit. Thus as particles collect on the filter and the flow rate decreases the corresponding decrease in dyamic pressure allows the

95 decrease in dyamic pressure allows the compressed spring to move the disk away from the converging portion of the conduit, thereby increasing the annular opening and the flow rate.

This alternative method of flow rate control is dependent upon the dynamic pressure of the flowing gas and is thus limited to high volume gas sampling. Additionally, because the dynamic pressure opposing the compressive spring varies with the square of the velocity of the gas and because the spring force is linear only over a relatively small compression, the flow rate is maintained constant only over a small range of flow rates, thereby preventing constant flow rate control during long sampling periods in which

While the present invention is generally directed to a method and apparatus for sampling a static body of gas, U.S. Patents 2,982,131; 3,859,842; and 3,965,747 disclose methods for sampling a moving body of gas, such as exhaust gases in a flue, in which the sample gas flows through the sampling device at generally the same velocity that it is flowing in the flue, thus permitting the sampling to be conducted 120 isokinetically.

The present invention provides a method and apparatus for maintaining the flow rate of a stream of gas constant throughout long duration sampling periods. The invention permits the accurate determination of particle concentration in a sample gas over the wide range of flow rates at which the gas may possibly be sampled. The vacuum pump which generates the stream of gas operates at its optimum design capacity,

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consumes a minimum of energy, generates minimal heat throughout the entire sampling period, and operates at a minimum noise level.

The invention provides a particle-bearing gas 5 sampling device which maintains the flow rate of a stream of gas relatively constant throughout the sampling period, and comprises generally a vacuum source for generating a stream of gas, a filter for collecting particles from the stream, a 10 flow rate selector located downstream of the pump for selecting the desired flow rate, and throttling means located between the vacuum source and the filter for varying the flow into the vacuum source in response to the static pressure 15 sensed in the stream. Additionally, a programmer electrically coupled to the vacuum source and to a flow sensing or pressure sensing transducer located downstream of the vacuum source initiates sampling at a predetermined time, and 20 terminates vacuum application at the end of a predetermined sampling period and also in the event the flow rate falls below a predetermined value. The device is also applicable to maintaining constant flow rate with a dichotomous sampler 25 such as a virtual impactor in which the sample gas is divided into two paths, the gas in the two paths flowing at substantially different flow rates and bearing particles of different sizes.

in a preferred embodiment the throttling means 30 for varying the flow into the vacuum source in response to the static pressure of the flowing gas stream is a modified pressure regulator and comprises generally a multi-chambered housing and a movable plunger located within the housing. 35 The flowing stream of gas passes through the first chamber and through an orifice within the first chamber. The movable plunger, which is responsive to the difference between the ambient pressure of the sample gas and the static pressure 40 in the flowing gas stream, has a lower conically shaped portion positioned in the orifice. The upper portion of the plunger is connected to a generally flexible diaphragm which separates the second and third chambers and which provides a fluid seal 45 between them. The second chamber of the housing is fluidly connected to the stream, preferably downstream of the vacuum source. Thus, the pressure in the second chamber is the static pressure of the gas in the stream 50 downstream of the vacuum source, i.e., on the compressor side of the vacuum pump. The third

ends of the housing by compressive springs.

At the initiation of gas sampling, the programmer turns on the vacuum pump and begins timing the sampling period. The flow rate selector, e.g. a valve, located downstream of the vacuum source, is varied until the desired flow rate is reached. The vacuum pump acts on the static body of sample gas to generate a flowing stream of gas which flows through the collection filter, through the first chamber and the orifice of

chamber is open to the ambient atmosphere,

sampled. Both the upper and lower end of the

55 plunger are operatively connected to respective

typically the atmosphere of the gas being

the throttling means, through the pump and valve and out to the atmosphere. As particles begin to collect on the collection filter the flow rate upstream of the vacuum source decreases.

70 Correspondingly the static pressure in the stream downstream of the pump and thus the pressure in chamber two of the throttling means decreases. Since the ambient pressure of the static body of gas being sampled remains relatively constant, a

75- pressure differential between the second and third chambers forces the diaphragm and thus the plunger downward so as to increase the annular opening defined by the conical plunger portion positioned in the orifice. This increased opening at the orifice relaxes the flow restriction at the orifice and compensates for the increased flow restriction at the collection filter. Accordingly, the flow rate is maintained relatively constant.

In the event of a surge in line voltage to the
vacuum pump, which would tend to increase the
pump speed and thus the flow rate of the stream,
the static pressure sensed in the stream
downstream of the vacuum source increases. In
such an instance, the pressure differential

between the second and third chambers of the
throttling means moves the diaphragm and the
plunger upward so as to decrease the annular
opening at the orifice. The result is a decrease in
flow rate despite the increased pump speed,
thereby maintaining the flow rate of the stream
relatively constant.

If for some reason the flow rate of the stream falls below a predetermined low value, a flow sensing or pressure sensing transducer located proximate the vacuum source signals the programmer to terminate vacuum application and the gas sampling device is automatically shut off.

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After a predetermined time period measured by the programmer the programmer terminates vacuum application and the sampling process is completed. The collection filters which were weighed before sampling began are weighed again to determine the weight of specific sized particles collected by the respective filters.

The gas sampling device includes means for adapting its use with a dichotomous sampler, such as a virtual impactor, which divides the sample gas into two paths having different flow rates. Generally speaking, a flow restrictor having an opening of fixed area is placed in the path having the reduced flow rate. This flow restrictor effectively chokes the flow of gas in the reduced flow rate path so as to maintain the flow rate in that path relatively constant regardless of the increasing flow restriction caused by particles collecting on the filter in that path. The gas flowing in the two paths is recombined downstream of the collection filters and upstream of the vacuum source.

Since the flow rate of the stream of gas is maintained relatively constant during the sampling period and since the sampling period is accurately timed by the programmer, the total volume of gas sampled from the static body of sample gas is accurately determined. Thus the ultimate

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accurately determined.

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Particular embodiments will now be described in the following description considered in connection with the accompanying drawings in which a preferred embodiment of the invention is illustrated by way of example.

Fig. 1 is a block diagram of the embodiment of gas sampling device. 10

Fig. 2 is a sectional view of the constant flow controller of the gas sampling device.

Fig. 3 is a block diagram of the embodiment modified for use with a dichotomous sampler.

The gas sampling device is illustrated in Fig. 1 and permits the accurate determination of particle concentration in the sample gas by generating a flowing stream of the gas at a relatively constant flow rate and for a predetermined time period. 20 Generally speaking, the gas sampling device comprises in series an inlet 10 for the gas to pass from the static body of sample gas, a particle collection means, such as filter 12, for collecting particles suspended in the gas, a constant flow controller 14, a vacuum source, such as vacuum pump 16, a flow rate selector, such as valve 18, means for measuring the flow rate, such as flowmeter 20, and interconnecting conduits 23, 25, 27, 29. Also provided with the gas sampling 30 device is a programmer 22 electrically coupled to pump 16 and to a pressure sensing transducer 24 for controlling the application of vacuum to the sample gas. The programmer 22 includes means e.g. suitable timing circuitry, for automatically

35 initiating and terminating vacuum application to

conducted at preselected intervals and for a

the sample gas so that sampling may be

predetermined period.

The constant flow controller 14, more fully depicted in Fig. 2, throttles the flow of the stream of gas upstream of pump 16 so that the gas flows at a relatively constant flow rate during the sampling period. The constant flow controller 14 comprises generally a multi-chambered housing 26 and a movable plunger 40 located therein. Housing 26 is operatively connected to the gas sampling device so that the stream of flowing gas passes through the lower chamber 28 in housing 26 during its passage from inlet 10 to pump 16. Located within chamber 28 is an orifice 30 through which the flowing stream of gas must pass during its passage through chamber 28. Lower chamber 28 is sealed from middle chamber 32 by means of a rigid plate 34 having an opening 29 therein. Middle chamber 32 is in turn separated and fluidly sealed from upper chamber 36 by a generally flexible diaphragm 38.

Secured to diaphragm 38 and projecting through opening 29 in plate 34 is a movable plunger 40. Plunger 40 has a lower portion 42 which has a generally conical configuration and which is positioned in the center of orifice 30 in chamber 28. Both lower portion 42 and upper portion 46 of plunger 40 are operatively connected to respective ends of housing 26 by

springs 50 and 52. Springs 50 and 52 and flexible diaphragm 38 permit the longitudinal movement of plunger 40 within housing 26. The longitudinal movement of plunger 40 varies the position of conically shaped lower portion 42 within orifice 30 in chamber 28, thereby varying the area of the generally annular shaped opening defined in orificie 30 by conically shaped portion 42 of plunger 40.

75 Middle chamber 32 of housing 26 is in fluid communication with the stream of gas, preferably at a point 33 downstream of vacuum pump 16, by means of opening 31 in chamber 32 and hose 35. Thus the pressure in middle chamber 32 is generally the static pressure of the gas in the stream at the point of fluid communication with the stream, such as depicted as point 33 on

Upper chamber 36 of housing 26 of the 85 constant flow controller 14 is open to the ambient atmosphere by means of opening 37. Thus the pressure in chamber 36 is the pressure of the static body of sample gas if the gas sampling device is surrounded by the sample gas.

conduit 27.

90 A screw member 54 is connected to spring 52 and thus to upper portion 46 of plunger 40 for adjusting the equilibrium position of plunger 40 in housing 26.

The invention can be better understood by 95 considering the function of the component parts during operation. Prior to the initiation of gas sampling, screw member 54 is adjusted so that lower portion 42 of the plunger 40 is positioned within orifice 30 in a manner that the annular opening 100 thereby defined provides a restriction to flow greater than the flow restriction provided by the initially particle-free filter 12.

The initiation of sampling is begun by programmer 22 which turns on pump 16 and begins timing the sampling period. The pump 16 applies a vacuum to the static body of sample gas and generates a stream of flowing gas which flows into inlet 10, through initially particle-free filter 12, through conduit 23, chamber 28 of 110 constant flow controller 14, conduit 25, and into pump 16. The stream of gas ultimately passes out pump 16, conduit 27, valve 18, and flowmeter 20, after which it exhausts to the ambient atmosphere. The valve 18, which is a variable flow 115 restriction in the stream, is varied to select the desired flow rate of the stream of sample gas. The selection of the flow rate is facilitated by flowmeter 20 which displays the flow rate as valve 18 is adjusted. Once valve 18 is adjusted so 120 that the desired flow rate has been reached, the sampling period has begun.

As the stream of particle-bearing gas generated by pump 16 passes through filter 12, particles are collected on filter 12. As particles continue to 125 collect on filter 12, the restriction to flow at filter 12 gradually increases and the flow rate of the stream gradually decreases. The gradual reduction in flow rate in this manner, in the absence of other factors, causes a corresponding reduction in the 130 static pressure of the gas downstream of the

vacuum source, and thus the pressure in middle chamber 32 decreases with increasing flow restriction at filter 12. While the pressure in chamber 32 decreases corresponding to increasing flow restriction at filter 12, the ambient pressure and thus the pressure in chamber 36 of constant flow controller 14 remains relatively constant. Thus, the pressure differential across diaphragm 38 between chambers 36 and 32 of 10 constant flow controller 14 changes. This changing pressure differential decreases the force acting on diaphragm 38 from the pressure in chamber 32. Plunger 40 is moved away from its initial equilibrium position by the force of spring 52 and thus is moved downward. The downward movement of plunger 40, and specifically of conically shaped lower portion 42 of plunger 40, increases the annular opening defined in orifice 30 by conically shaped lower portion 42 of plunger 20 40, thereby relaxing or decreasing flow restriction by particles collecting on filter 12 is thus automatically and immediately compensated by a decrease in flow restriction at orifice 30, thereby maintaining flow rate through the system 25 relatively constant. Thus, despite continued collection of particles on filter 12 during sampling and the corresponding reduction in flow rate at

30 entire sampling period. After the gas sampling device has been operating for the predetermined time period, a timer in programmer 22 terminates vacuum application to the sample gas by shutting off pump 35 16. The total volume of gas sampled during this sampling period is thus readily and accurately determined from a knowledge of the volumetric flow rate, which was maintained constant, and the duration of the sampling period. The accurate 40 determination of the total volume of gas sampled facilitates the determination of the mass of particles per unit volume in the sample gas. The filter which was weighed before sampling began is weighed again to determine the total weight 45 of particles collected.

filter 12, pump 16 operates at constant speed and

at its optimum design capacity throughout the

If for some reason, e.g. abnormally rapid clogging of filer 12, the flow decreases below the limit of controllability, transducer 24, which is preferably a pressure transducer or alternatively a 50 flow transducer signals programmer 22 to shut off vacuum pump 16. Any conventional circuitry, e.g. a relay or suitable solid state equivalent, in programmer 22 will perform this desired function.

Referring now to Fig. 3, means are provided for adapting the gas sampling device so as to maintain constant flow control in a dichotomous sampler, such as virtual impactor 60, which directs the sample gas into two paths.

60 Virtual impactor 60 comprises an inlet 61 for the passage of the sample gas and for the various sized particles suspended in the sample gas, two outlets 63, 65 connected respectively to conduits 23, 62, and two filters 68, 66 located proximate respective outlets 63, 65. Conduit 23 connected to outlet 63 is part of the gas sampling device described above. Conduit 62 is in fluid communication with conduit 25 of the above-described gas sampling device between constant flow controller 14 and pump 16. Located between outlet 65 and conduit 25 and in fluid communication with conduit 62 are a flowmeter 72 and a flow restrictor 70. Conduits 23 and 62 confine the gas to flow in two paths.

The gas flowing in the two paths flows at

The gas flowing in the two paths flows at substantially different flow rates and bears particles of different sizes. In the embodiment depicted in Fig. 3, the "coarse" particles, i.e. those larger than the particle size cut-point of virtual impactor 60, pass through outlet 65 and are borne by gas flowing in the path confined by conduit 62 at a flow rate that is less than the flow rate of the gas flowing in conduit 23. The coarse particles pass from inlet 61 to outlet 65 because of their greater momentum. The "fine" particles, i.e. those smaller than the partical size cup-point of virtual impactor 60, have a lesser momentum and are directed from inlet 61 into outlet 63 by gas

90 10, than the flow rate of the gas inconduit 62. the fine particles are collected on filter 68. Generally speaking, in such a virtual impactor, all of the coarse particles from inlet 61 pass through outlet 65 and are collected on filter 66. However, some
95 of the fine particles, the exact amount being proportional to the flow rates in the respective paths, also pass from inlet 61 through outlet 65 and are collected on filter 66.

flowing at a flow rate greater, e.g., by a factor of

The gas which has been diverted into two paths
100 by virtual impactor 60 is recombined downstream
of filters 66, 68 and upstream of pump 16. The
flow restrictor 70 located in the path confined by
conduit 62 is an adjustable valve which allows
preselecting the desired flow rate. The preselected
flow rate is monitored by flowmeter 72. The flow
through flow restrictor 70 is choked because of
the relatively small area of the opening provided
by flow restrictor 70 and because the pressure in
conduit 25 upstream of vacuum pump 16 is
substantially less than atmospheric. Since the flow
rate through filter 66 is relatively small, e.g. onetenth that through filter 68, clogging of filter 66 is

tenth that through filter 68, clogging of filter 66 is not a problem, the flow through conduit 62 remains relatively constant and the flow through flow restrictor 70 remains choked.

In the operation of the gas sampling device

with virtual impactor 60, fine particles collect on filter 68 and the flow rate in conduit 23 gradually decreases. Constant flow controller 14

120 compensates for this gradual increase in flow restriction by decreasing the flow restriction at orifice 30 in the manner as above described.

Despite the flow rate compensation provided by constant flow controller 14, the flow rate in the outlet 65 and conduit 62, i.e., the reduced flow rate path, remains constant. Thus, throughout the entire sampling period the total flow rate is maintained relatively constant despite the

increasing flow resistance provided by particles collecting on filters 68, 66. Since the flow rate in

the path in which gas bearing the coarse particles is flowing, i.e., conduit 65, is also maintained relatively constant because of the choked condition provided by flow restrictor 70, the flow 5. rate in the path in which gas bearing the fine particles is flowing, i.e. outlet 63, must also be maintained constant.

At the termination of the sampling period, which occurs in the manner as above described for the gas sampler shown in Fig. 1, the two filters 68, 66, which were weighed before sampling, are again weighed to determine the total weight of particles collected on each of them. A correction to the weight of filter 66 is made for the portion of 15 fine particles which have been collected on filter 66. This correction may be accurately made because the weight of fine particles collected on filter 66 is directly related to the flow rates in the respective paths. Thus the maintainance of constant total flow rate, as well as constant flow rate in each of the paths, facilitates the ultimate determination of the concentration of particles of a specific size when a dichotomous sampler is

As should now be apparent, the present 25 invention provides a method and apparatus for the rapid and accurate determination of particle concentration in a particle-bearing sample gas. The determination of particle concentration is facilitated by maintenance of constant flow rate during the sampling period. Because constant flow rate is maintained by sensing the static pressure of the flowing stream of gas as particles gradually collect on the collection filter and thereby gradually decrease the flow rate, the gas sampling device is capable of maintaining constant flow rate during both high and low volume gas sampling. Additionally, the sensing of the static pressure downstream of the vacuum pump so as to throttle the flow rate upstream of the vacuum pump permits the pump to operate at a constant speed and at its optimum design capacity, thereby minimizing energy consumption, eliminating the addition of heat energy to the stream, and 45 minimizing the noise level.

When used with a dichotomous sampler, the present invention permits the accurate determination of the concentration of various sized particles suspended in a sample gas by maintaining the flow rate in the two paths of the dichotomous sampler constant despite the fact that particles are collecting on the filters in both

While the preferred embodiments of the present invention have been illustrated in detail, it should be apparent that modifications and adaptations of those embodiments will occur to those skilled in the art.

CLAIMS

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1. A method of sampling a particle-bearing gas 60 for the determination of particle concentration, the gas being sampled by a device of the type having a source of reduced pressure, the method including

65 applying reduced pressure to the gas to be sampled so as to generate a stream of flowing gas;

collecting particles from said stream; sensing the static pressure in the stream varying with time; and

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regulating the flow of said stream upstream of the source in response to variations in the said static pressure, to tend to maintain the rate of flow of said stream constant.

- 2. A method according to Claim 1 including the step of preselecting the rate of flow of the stream from a range of available rates.
- 3. A method according to Claim 1 or Claim 2 including the step of, prior to collecting particles from said stream, sorting the particles into groups according to size.
- 4. A method according to any one of the preceding claims which include sensing the static pressure downstream of the source.
- 5. A method according to Claim 4 wherein the step of regulating the flow includes the steps of allowing increase in the flow in response to a decrease in the sensed pressure and causing decrease in the flow in response to an increase in the sensed pressure whereby to tend to maintain the sensed pressure constant.
- A method according to any one of the preceding claims including terminating the application of reduced pressure when the rate of flow of said stream reaches a predetermined value.
- 7. A method according to any one of the preceding claims including timing the duration of said application and terminating said application when said timed duration reaches a predetermined value.
- 8. A method according to any one of the preceding claims including the step of comparing the sensed pressure with the ambient pressure of 105 the gas being sampled.
 - A method of determining the concentration of particles in a sample gas wherein reduced pressure is applied to the sample gas so as to generate a flowing stream of gas and wherein particles are collected on a filter located in the stream of flowing gas, which includes

preselecting the volumetric rate of flow of the stream;

restricting the flow of the stream at a point 115 between the filter and the source of the reduced pressure by an extent greater than the flow restriction provided by the particle-free filter;

> continuously sensing the static pressure of the stream downstream of the source; and

relaxing the restriction to a flow between the filter and the source in response to a decrease in said sensed pressure downstream so that the flow restriction at said restriction point decreases in response to the decrease in said sensed pressure 125 downstream, whereby the volumetric rate of flow of the stream is maintained generally at said preselected rate as particles are collected on the initially particle-free filter in the stream and the flow restriction at the filter gradually increases.

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- 10. A method of determining the concentration of particles in a sample gas substantially as herein described with reference to the accompanying drawings.
- 11. An apparatus for the determination of particle concentration is particle-bearing sample gas, the apparatus comprising in combination:

a source for applying reduced pressure to the sample gas so as to generate a flowing stream of gas:

means for collecting particles from the flowing stream; and

a regulator responsive to the static pressure in the stream for regulating the pressure between 15 the particle collecting means and source.

12. Apparatus according to Claim 11 wherein the regulator senses the ambient pressure of the sample gas.

13. Apparatus according to Claim 11 or Claim 12 wherein the regulator includes a housing having an orifice through which the stream passes, and an obturator movable within the orifice and responsive to the difference between the static pressure in the stream and the ambient pressure of the sample gas for varying the effective opening of said orifice.

14. Apparatus according to Claim 11, Claim 12 or Claim 13 including means for selecting the volumetric rate of flow of the stream, the flow rate selecting means being located downstream of the source.

15. Apparatus according to any one of Claims 11 to 14 including means for measuring the volumetric rate of flow of the stream.

16. Apparatus according to any one of Claims
11 to 15 including means coupled to the source and responsive to pressure for terminating the operation of the source and therewith the flow of the stream when the pressure reaches a predetermined level.

17. Apparatus according to any one of Claims 11 to 16 including means coupled to the source and responsive to the rate of flow of the stream for terminating the flow of the stream.

18. Apparatus according to any one of Claims 11 to 17 including a timer electrically coupled to the source for terminating the application of vacuum to the sample gas at the end of a predetermined period of time.

19. Apparatus according to any one of claims11 to 18 wherein the regulator responds to the static pressure of the stream downstream of the source.

20. Apparatus according to any one of claims 11 to 19 including a second particle collecting means in fluid communication with said source for flow of part of the stream through it; a flow restrictor between the second particle collecting

means and the source for maintaining the rate of flow of gas through said second particle collecting means at less than the volumetric rate of flow of gas through said first particle collecting means.

21. Apparatus for the dichotomous sampling at a generally constant volumetric flow rate of a particle-bearing gas, the apparatus including

a vacuum pump for generating a stream of flowing gas;

a flow rate selector valve in fluid communication with said pump for selecting the volumetric flow rate of said stream;

a virtual impactor in fluid communication with the sample gas and said pump for dividing the sample gas into two paths;

a first filter located in said first path, and in fluid
 communication with said virtual impactor and said pump for collecting particles from the gas flowing in said first path;

a second filter located in said second path and in fluid communication with said virtual impactor and said pump for collecting particles from the gas flowing in said second path;

a flow resistor located in said second path and in fluid communication with said second filter and said pump for maintaining the flow rate of gas in said second path relatively constant and less than the flow rate of gas in said first path;

means upstream of said pump for combining the gas flowing in said two paths into said stream; and

90 a pressure regulator in fluid communication with and located between said first filter and said pump, said pressure regulator further comprising means for sensing the static pressure of the gas in said stream, a chamber through which the gas 95 flow from said first filter to said pump, said chamber having an orifice therein, and means responsive to the difference in pressure between the ambient pressure of the sample gas and said sensed static pressure for varying the opening at 100 said orifice and therewith the rate of flow of said stream, whereby as particles collected on said first filter tend to reduce the flow rate of the gas flowing in said filter path and therewith the sensed static pressure, the opening at said orifice is 105 increased so as to maintain the volumetric flow rate of said stream generally at the rate selected by said flow rate selector.

22. Apparatus according to Claim 11 substantially as herein described with reference to 110 and as illustrated in Figs. 1 and 2 of the accompanying drawings.

23. Apparatus according to Claim 21
substantially as herein described with reference to and as illustrated in Figs. 2 and 3 of the
115 accompanying drawings.

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